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Appl. No. 09/754,264  
Amendment/Response in reply  
to Office Action of July 26, 2004.

**IN THE UNITED STATES  
PATENT AND TRADEMARK OFFICE**

Appl. No.: 09/754,264

Applicant(s): Tetsuo Usami, et al.

Filed: January 5, 2001

Title: Deposition Method For Wiring Thin Film  
TC/A.U.: 2800/2814

Examiner: S. H. Rao

Atty. Docket: OKI.202

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On: 1 November 2004

By: Michelle Welgoss  
Michelle Welgoss

**AMENDMENT and/or RESPONSE UNDER 37 C.F.R. § 1.116**

Honorable Assistant Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated July 26, 2004, kindly reconsider the application in view of the following amendments and remarks. Petition is hereby made for a one-month extension of time under 37 C.F.R. 1.136(a). The fee required under 37 C.F.R. 1.17 may be charged to Deposit Account No. 50-0238.

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- 1. Amendments to the claims** reflected in the complete listing of the claims, which begins on page 3 of this paper; and
- 2. Remarks/Discussion of issues**, which begin on page 5 of this paper.